

APR 8 2005

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To:	United States Patent & Trademark Office	From:	Leslie S. Szivos, Ph.D.
Fax:	1-703-872-9306	Pages:	7 (including fax cover sheet)
Phone:		Date:	April 8, 2005
Re:	Omer H. Dokumaci, et al. U.S. Patent Appln. No. 10/696,686 Our Docket: 16506	CC:	

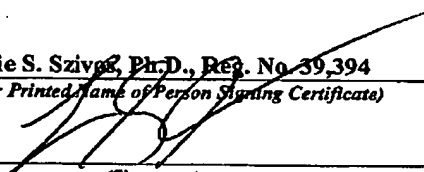
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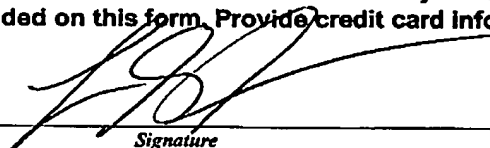
Attached for submission to the U.S. Patent and Trademark Office are the following:

- **Certificate of Transmission by Facsimile (2)**
- **General Transmittal Letter (2)**
- **Response to Restriction Requirement**

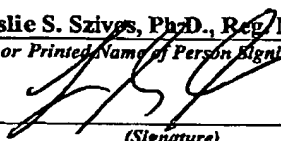
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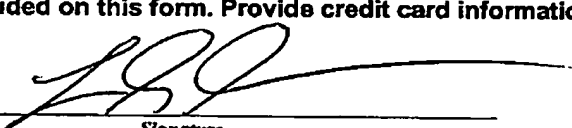
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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			
Applicant(s): Omer H. Dokumaci, et al.			
Docket No. FIS920030115US (16506)			
Application No. 10/696,686	Filing Date October 28, 2003	Examiner Erik J. Kielin	Group Art Unit 2813
Invention: NANOCIRCUIT AND SELF-CORRECTING ETCHING METHOD FOR FABRICATING SAME			
I hereby certify that this _____ <div style="text-align: center;">Response to Restriction Requirement <small>(Identify type of correspondence)</small></div> is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>(703) 872-9306</u>) on <u>April 8, 2005</u> <div style="margin-left: 100px;"><small>(Date)</small></div>			
<div style="text-align: right; margin-right: auto;"><div style="margin-bottom: -1em;"><u>Leslie S. Szivoss, Ph.D., Reg. No. 39,394</u> <small>(Typed or Printed Name of Person Signing Certificate)</small></div><div> <small>(Signature)</small></div></div>			
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TRANSMITTAL LETTER (General - Patent Pending)				Docket No. FIS920030115US (16506)					
In Re Application Of: Omer H. Dokumaci, et al.									
Application No. 10/696,686	Filing Date October 28, 2003	Examiner Erik J. Kielin	Customer No. 23389	Group Art Unit 2813	Confirmation No. 5262				
Title: NANOCIRCUIT AND SELF-CORRECTING ETCHING METHOD FOR FABRICATING SAME									
<u>COMMISSIONER FOR PATENTS:</u>									
Transmitted herewith is: Response to Restriction Requirement									
in the above identified application.									
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<input type="checkbox"/> A check in the amount of _____ is attached.									
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 19-1013/SSMP as described below.									
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WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.									
 _____ <i>Signature</i>			Dated: April 8, 2005						
Leslie S. Szivos, Ph.D. Registration No. 39,394 SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza, Suite 300 Garden City, New York 11530 (516) 742-4343			<table border="1" style="width: 100%; border-collapse: collapse;"><tr><td style="text-align: center;">I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" (37 CFR 1.8(a)) on _____</td></tr><tr><td style="text-align: center;">(Date)</td></tr><tr><td style="text-align: center;">_____ <i>Signature of Person Mailing Correspondence</i></td></tr><tr><td style="text-align: center;">_____ <i>Typed or Printed Name of Person Mailing Correspondence</i></td></tr></table>			I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" (37 CFR 1.8(a)) on _____	(Date)	_____ <i>Signature of Person Mailing Correspondence</i>	_____ <i>Typed or Printed Name of Person Mailing Correspondence</i>
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	 <i>(Signature)</i>	
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<input type="checkbox"/> Charge the amount of _____					
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 _____ <i>Signature</i>			Dated: April 8, 2005		
Leslie S. Szivos, Ph.D. Registration No. 39,394 SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza, Suite 300 Garden City, New York 11530 (516) 742-4343					
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Omer H. Dokumaci, et al. **Examiner:** Erik J. Kielin
Serial No: 10/696,686 **Art Unit:** 2813
Filed: October 28, 2003 **Docket:** FIS920030115US (16506)
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FABRICATING SAME

Confirmation No: 5262

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. §§1.111 AND 1.143

Sir:

In response to the Office Action dated March 8, 2005, applicants provisionally elect, without traverse, the subject matter of Group I, i.e., Claims 1-16 for continued prosecution in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

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Dated: April 8, 2005



Leslie S. Szivos, Ph.D.